



1763 ✓ JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christopher L. Schutte, et al.
Serial No: 10/802,951
Examiner: Sylvia MacArthur
Filed: 03/16/2004
For: SEMICONDUCTOR WAFER HANDLER

Docket No: TI-34807.1
Conf. No: 4211
Art Unit: 1763

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 11-23-04.


Ann Trent

Dear Sir:

Responsive to the Office Action mailed August 9, 2004, in connection with the above identified application, Applicants respectfully submit the following remarks.